

Title (en)

METHOD FOR PRODUCING AND STRUCTURING A ZINC OXIDE LAYER

Title (de)

VERFAHREN ZUR HERSTELLUNG UND STRUKTURIERUNG EINER ZINKOXIDSCHICHT

Title (fr)

PROCÉDÉ DE PRODUCTION ET STRUCTURATION D'UNE COUCHE D'OXYDE DE ZINC

Publication

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Application

**EP 10759568 A 20100807**

Priority

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Abstract (en)

[origin: WO2011026455A1] The invention relates to a method for producing ZnO contact layers for solar cells. The layers are etched by means of hydrofluoric acid in order to produce a texture.

IPC 8 full level

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Citation (search report)

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DOCDB simple family (publication)

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